

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 4125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,
SOI SUBSTRATE, SEMICONDUCTOR
DEVICE, DISPLAY DEVICE, AND
MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: Schillinger, Laura M.

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(d),
BEFORE PAYMENT OF ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant requests entry and consideration of references previously submitted with an Information Disclosure Statement (IDS) filed February 21, 2008 under different rule. Applicant has determined that although the February 21, 2008 IDS included authorization to charge the deposit account, the IDS has not been forwarded to the Examiner. Subsequently, the appropriate fee is being submitted concurrently herewith, to be provided in conjunction with the statement under 37 CFR 1.97(e) made in the February 21, 2008 IDS in order to satisfy the requirements for submission under 37 CFR 1.97(d).

As evidence of Applicant's previous submission of the references cited on the Form PTO/SB08 in connection with the present application, Applicant encloses a copy of the E-filing

receipt indicating receipt of the references cited on the Form PTO/SB08 by the United States Patent and Trademark Office.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Dated: April 2, 2008

Respectfully submitted,

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Attachments: Copy of E-filing Receipt

Copy of PTO/SBO8 filed 02/21/08